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AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP 2814
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q76993

Sadayuki OHNISHI

Appln. No.: 10/646,709

Group Art Unit: 2814

Confirmation No.: 9821

Examiner: Phat X. CAO

Filed: August 25, 2003

For: SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

AMENDMENT UNDER 37 C.F.R. § 1.116

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 9, 2005, please amend the above-identified application as follows on the accompanying pages.

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